

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s): Park, et al.	Group Art Unit: 2814
Application No.: 09/173,129	Examiner: Peralta, G.
Filed: 10/15/1998	Tech Grp Fax: TC 2800 BF: 703-872-9318
Title: Selective Oxidation for Semiconductor Device Fabrication	I hereby certify that this correspondence is being <input type="checkbox"/> deposited with the United States Postal Service with sufficient postage as first class mail in an envelope addressed to Commissioner for Patents, Washington, D.C. 20231, or <input checked="" type="checkbox"/> facsimile transmitted to the U.S. Patent and Trademark Office, on <u>3/5/2003</u>
Attorney Docket No.: TI-25320	<u>Alan W. Lintel</u> <u>3/5/2003</u> Name Date

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Commissioner for Patents
Washington, D.C. 20231

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PETITION FOR EXTENSION OF TIME UNDER 37 CFR §1.136

TECHNOLOGY CENTER 2800

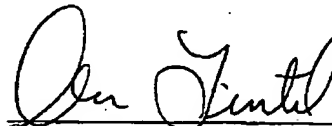
Dear Sir:

Applicant hereby petitions for an Extension of Time for responding to the Office Action dated November 5, 2002, for one month from February 5, 2003 to March 5, 2003.

The Commissioner is hereby authorized to charge the amount of \$ 110.00 plus any other fees or credit any overpayment to Deposit Account No. 01-1615 of Anderson, Levine and Lintel, LLP.

This petition is submitted in duplicate.

Respectfully Submitted,



Alan W. Lintel
Attorney/Agent for Applicant(s)
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March 5, 2003
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